

S/N 09/259,762

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Zhiping Yin et al.

Examiner: Unknown

Serial No.: 09/259,762

Group Art Unit: Unknown

Filed: March 1, 1999

Docket: 303.531US1

Title: OXYGEN PLASMA TREATMENT FOR NITRIDE SURFACE TO REDUCE
PHOTO FOOTING

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

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In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants further request that a copy of the 1449 form, initialed by the Examiner to indicate that all listed citations have been considered, be returned with the next official communication.

Please charge any additional fees or credit any overpayment to Account No. 19-0743.

The Examiner is invited to contact the Applicants' Representatives at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

ZHIPING YIN ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
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Date 21 May 1999 By Janal M. Kalis
Janal M. Kalis
Reg. No. 37,650

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Assistant Commissioner of Patents, Washington, D.C. 20231 on May 21, 1999.

Name Janal M. Kalis

Signature Janal M. Kalis

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We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ A return postcard.
- ☒ An Information Disclosure Statement (1 pg.), Form 1449 (1 pg.), and copies of 14 cited references.

Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this Transmittal Letter and the paper, as described above, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this 21st day of May, 1999.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
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By: [Signature]
Atty: Janal M. Kalis
Reg. No. 37,650

Customer Number **21186**

(GENERAL)

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